

10/582860

AP20 Rec'd PCT/PTO 14 JUN 2006

S/N: TBA

06/14/2006

Docket No.: SUG-193-PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: **TO BE ASSIGNED**

Confirmation No.: **TO BE ASSIGNED**

Applicant: **Toru YAMADA et al.**

Art Unit: **TO BE ASSIGNED**

Filed: **June 14, 2006**

Examiner: **TO BE ASSIGNED**

Docket No: **SUG-193-PCT**

Customer No: **28892**

For: **Vapor Phase Growth Apparatus and Method of Fabricating Epitaxial Wafer**

PRELIMINARY AMENDMENT

US Patent & Trademark Office
Customer Service Window, Mail Stop: PATENT APPLICATIONS
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

After assigning a serial number to the above-captioned application and before calculating the fee, please undertake the following changes:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.

An Appendix including the Abstract is attached following page 7 of this paper.